Electronic Acknowledgement Receipt				
EFS ID:	1028686			
Application Number:	10624931			
Confirmation Number:	6762			
Title of Invention:	Spin-valve magnetoresistive thin film element			
First Named Inventor:	Masamichi Saito			
Correspondence Address:	Jasper W. Dockrey BRINKS HOFER GILSON & LIONE P.O. Box 10395 - Chicago IL 60610 US 3123214249 -			
Filer:	Gustavo Siller Jr./Marianne Hall			
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Application Type:	Utility			
International Application Number:				
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no

Submitted with Payment

File Listing:

Document Number	Document Description	File Name	File Size(Bytes)	Multi Part	Pages		
1		04-21-06-Restriction-Respon se.pdf	8188907	yes	9		
	Multipart Description						
	Doc Desc		Start	End			
	Transmittal letter		1	1			
	Response to Election / Restriction Filed		2	9			
Warnings:							
Information:							
Total Files Size (in bytes)			8188907				

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New Applications Under 35 U.S.C. 111

If a new application is being filed and the application includes the necessary components for a filing date (see 37 CFR 1.53(b)-(d) and MPEP 506), a Filing Receipt (37 CFR 1.54) will be issued in due course and the date shown on this Acknowledgement Receipt will establish the filing date of the application.

National Stage of an International Application under 35 U.S.C. 371

If a timely submission to enter the national stage of an international application is compliant with the conditions of 35 U.S.C. 371 and other applicable requirements a Form PCT/DO/EO/903 indicating acceptance of the application as a national stage submission under 35 U.S.C. 371 will be issued in addition to the Filing Receipt, in due course.